Amendments to the Claims

Please amend claims 1, 7-11, 13-15, 18, 20, and 21. Please cancel claim 7. The

following listing of claims replaces all prior versions and listings of claims in the present

application:

1. (Currently Amended) A charge coupled device made according to a standard

CMOS process on a substrate of a first conductivity type, the charge coupled device comprising:

a dielectric layer overlaying at least a portion of the substrate, the dielectric layer being a

CMOS gate dielectric layer;

at least two gate electrodes overlaying the dielectric layer, the at least two gate electrodes

configured to define at least two charge wells; in the substrate of the first conductivity type, said

charge wells being formed in response to a bias potential applied to the at least two gate

electrodes, the at least two gate electrodes being separated by an inter-electrode gap in the

substrate of the first conductivity type between the at least two gate electrodes; and

apparatus for stabilizing the inter-electrode gap selected from a group consisting of:

a semiconductor region of the first conductivity type, formed in the interelectrode gap,

but having a different dopant concentration than the substrate for stabilizing the inter-electrode

gap; and

means for applying respective bias potentials to the at least two gate electrodes, the bias

potentials being sufficient to cause a fringing field to extend across the inter-electrode gap from

at least one of the at least two gate electrodes.

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(Canceled)

3. (Previously Presented) A charge coupled device according to claim 1, wherein

the apparatus for stabilizing the inter-electrode gap further includes:

a further dielectric layer formed over the at least two gate electrodes; and

a further gate electrode formed overlying the further dielectric layer and selectively

positioned over the inter-electrode gap.

4. - 7. (Canceled)

8. (Currently Amended) A charge coupled device according to claim 1, wherein a

first one of the charge well areas and its corresponding gate electrode form a photogate optical

sensor and the charge coupled device further comprises:

a well region a charge barrier well of a first conductivity type, adjacent to the photogate

optical sensor for forming a charge barrier well, the charge barrier well being configured to

divert photocarriers into at least the photogate optical sensor; and

a diffusion region of a second conductivity type, different from the first conductivity

type, the diffusion region being formed inside the charge barrier well and being configured as an

anti-blooming drain.

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9. (Currently Amended) A charge coupled device according to claim 8, further

including:

a further well region a further charge barrier well of the first conductivity type, distal to

the photogate optical sensor and the anti-blooming drain , the further well region forming a

further charge barrier well; and

a plurality of further diffusion regions of the second conductivity type in the further

charge barrier well, the plurality of further diffusion regions forming a charge sink and a

plurality of transistors, a second diffusion region of the second conductivity type in the further

charge barrier well, the second diffusion region forming a charge sink, wherein one of the at least

two gate electrodes that is not a photogate optical sensor overlies a portion of the further charge

barrier well adjacent to the charge sink.

10. (Currently Amended) A charge coupled device according to claim 9, further

comprising a plurality of further diffusion regions of the second conductivity type in the further

charge barrier well adjacent to the charge sink and forming a plurality of transistors, wherein the

plurality of transistors include a reset transistor and an emitter follower amplifier, both coupled

to the charge sink.

11. (Currently Amended) An optical sensor circuit for receiving photocarriers from a

source and being formed on a single monolithic substrate comprising:

a charge coupled device (CCD) array, the array being formed of a plurality of single

polysilicon CMOS pixels, each pixel including,

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a semiconductor layer of a first conductivity type formed on the substrate;

a first dielectric layer overlaying the semiconductor layer, the first dielectric layer being a

CMOS gate dielectric layer;

at least two gate electrodes overlaying the first dielectric layer and configured to define at

least two charge wells, respectively, in the semiconductor layer, in response to a bias potential

applied to the at least two gate electrodes, wherein adjacent ones of the at least two gate

electrodes are separated by an inter-electrode gap in the semiconductor layer, a combination of

one of the at least two charge wells and its respective overlaving gate electrode forming a

photogate optical sensor and a combination of another one of the at least two charge wells and its

respective overlaying gate electrode forming a transfer gate; and

apparatus for stabilizing the inter-electrode gap selected from a group consisting of:

a semiconductor region of the first conductivity type, formed in the inter-electrode gap

for stabilizing the inter-electrode gap, but having a different dopant concentration than the

semiconductor layer; and

means for applying respective bias potentials to the at least two gate electrodes, the bias

potentials being sufficient to cause a fringing field to extend across the inter-electrode gap from

at least one of the at least two gate electrodes.

12. (Canceled)

13. (Currently Amended) An optical sensor according to claim 11, further

comprising:

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a well region a charge barrier well of the first conductivity type, adjacent to the photogate

optical sensor for forming a charge barrier well, the charge barrier well being configured to

divert photocarriers into at least the photogate; and

a diffusion region of a second conductivity type, different from the first conductivity

type, the diffusion region being formed inside the charge barrier well and being configured as an

anti-blooming drain.

14. (Currently Amended) An optical sensor according to claim 13, further including:

a further well region a further charge barrier well of the first conductivity type, distal to

the photogate optical sensor and the anti-blooming drain, the further well region forming a

further charge barrier well; and

a plurality of further diffusion regions of the second conductivity type in the further

charge barrier well, the plurality of further diffusion regions forming a charge sink and a

plurality of transistors, a second diffusion region of the second conductivity type in the further

charge barrier well, the second diffusion region forming a charge sink, wherein one of the at

least two gate electrodes that is not a photogate optical sensor overlies a portion of the further

charge barrier well adjacent to the charge sink.

15. (Currently Amended) A charge coupled device according to claim 13, further

comprising a plurality of further diffusion regions of the second conductivity type in the further

charge barrier well adjacent to the charge sink and forming a plurality of transistors, wherein the

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plurality of transistors include a reset transistor and an emitter follower amplifier, both coupled

to the charge sink.

16. (Original) An imager system comprising:

a single monolithic integrated circuit including:

a charge coupled device (CCD) imager array; and

a complementary metal oxide semiconductor (CMOS) analog to digital converter coupled

to receive image signals from the CCD imager array.

17. (Original) A camera system comprising:

a single monolithic integrated circuit including;

a charge coupled device (CCD) imager array; and

a complementary metal oxide semiconductor (CMOS) analog to digital converter coupled

to receive image signals from the CCD Imager array; and

optics configured to focus radiation onto the CCD imager array.

18. (Currently Amended) A charge coupled device made according to a standard

single polysilicon CMOS process, the charge coupled device comprising: a substrate of a first

conductivity type;

a well region of a second conductivity type, opposite to the first conductivity type;

an oxide layer formed over at least the well region, the oxide layer being a CMOS gate

oxide layer;

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first and second polysilicon gate electrodes formed on the oxide layer over the well

region, the first and second gate electrodes being separated by an inter-electrode gap in the well

region, wherein the combination of the first and second polysilicon gate electrodes, the oxide

layer and the well region form a buried channel CCD register; and

apparatus for stabilizing the inter-electrode gap selected from a group consisting of:

a semiconductor region of the second conductivity type, formed in the inter-electrode gap

of the well region for stabilizing the inter-electrode gap, but having a different dopant

concentration than the well region; and

means for applying respective bias potentials to the at least two gate electrodes, the bias

potentials being sufficient to cause a fringing field to extend across the inter-electrode gap from

at least one of the at least two gate electrodes.

(Canceled)

20. (Currently Amended) A back illuminated imager comprising:

a substrate of a first conductivity type having a front side and a back side;

a photodetector CCD pixel structure formed in the front side of the substrate;

a well region of a second conductivity type, opposite to the first conductivity type,

formed in the front side of the substrate and separate from the photodetector CCD pixel structure,

the well region and the substrate forming a semiconductor junction; and

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at least one diffusion region in the well region of the second conductivity type forming

the a component of the a back illuminated imager, said CCD pixel structure overlying said at

least one diffusion region;

whereby the component of the back illuminated imager is shielded from photocarriers

generated in response to photons received at the back side of the substrate by the semiconductor

junction.

21. (Currently Amended) An electronic camera system comprising The charge

coupled device according to claim 18, further comprising:

an imager formed according to one of claims 18 and 20; and optics that are configured to

focus radiation onto the imager back side of the substrate.

22. - 30. (Canceled)

(Previously Presented) The charge coupled device of claim 11, wherein the 31.

semiconductor layer is a transmission channel and the transmission channel is a CMOS N-well.

32. (Previously Presented) The charge coupled device of claim 1, wherein

the at least two gate electrodes include at least two CMOS polysilicon gate electrodes.

33. (New) A charge coupled device according to claim 18, further comprising:

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a charge barrier well of a first conductivity type adjacent the first polysilicon gate

electrode and distal to the second gate electrode; and

a diffusion region of a second conductivity type, different from the first conductivity

type, the diffusion region being formed inside the charge barrier well and being configured as an

type, the diffusion region being formed made the charge barrier wen and being configured as an

anti-blooming drain.

34. (New) A charge coupled device according to claim 33, further including:

a further charge barrier well of the first conductivity type adjacent to the second

polysilicon gate electrode and distal to the first polysilicon gate electrode and the anti-blooming

drain; and

a second diffusion region of the second conductivity type in the further charge barrier

well, the second diffusion region forming a charge sink, wherein the second gate electrode

overlies a portion of the further charge barrier well adjacent to the charge sink.

35. (New) A charge coupled device according to claim 34, further comprising a

plurality of further diffusion regions of the second conductivity type in the further charge barrier

well adjacent to the charge sink and forming a plurality of transistors, wherein the plurality of

transistors include a reset transistor and an emitter follower amplifier, both coupled to the charge

sink.

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